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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sept. 2, 2005

TOWNSEND and TOWNSEND and CREW LLP

By: Margaret K. Stephen

IFW

PATENT

Docket No.: 16869N-099100US

Client Ref. No.: NT1355US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Ryo NAKAGAKI et al.

Application No.: 10/699,528

Filed: October 31, 2003

For: METHOD AND SYSTEM FOR
MANUFACTURING A
SEMICONDUCTOR DEVICE

Examiner: Kin Chan Chen

Art Unit: 1765

Response to Restriction Requirement

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Restriction Requirement dated August 5, 2005, counsel for Assignee elects to prosecute the claims of Group I, claims 1-13, without traverse.

If the Examiner believes a telephone conference would expedite prosecution of this application, please telephone the undersigned at 650-324-6303.

Respectfully submitted,

Robert C. Colwell
Reg. No. 27,431

TOWNSEND and TOWNSEND and CREW LLP
Two Embarcadero Center, Eighth Floor
San Francisco, California 94111-3834
Tel: (415) 576-0200
Fax: (415) 576-0300
RCC:mks